



#12/EX  
5/10/03  
Surle

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT : Dong-Su Kim  
SERIAL NO. : 09/899,784 EXAMINER : Fernando L. Toledo  
FILED : July 5, 2001 ART UNIT : 2823  
FOR : METHOD OF FABRICATING SILICA MICROSTRUCTURES

Certificate of Mailing Under 37 CFR 1.8

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to the ASSISTANT COMMISSIONER FOR PATENTS, WASHINGTON, DC 20231 on April 28, 2003.

Steve S. Cha, Reg. No. 44,069  
(Name of Registered Representative)

[Signature] 4/29/03  
(Signature and Date)

PETITION FOR ONE MONTH EXTENSION OF TIME

ASSISTANT COMMISSIONER FOR PATENTS  
WASHINGTON, D.C. 20231

Dear Sir:

Applicants hereby request that the period for responding to the Office Action, now set to expire on March 27, 2003, be extended by one (1) month, so as to expire on April 28, 2003 as April 27, 2003 was a Sunday.

As Applicants are associated with a large entity, a check in the amount of \$110.00 is enclosed to cover the one-month extension herein requested. The Commissioner is further authorized to charge any deficiencies or to credit any overages to Deposit Account No. 502-470.

Favorable action on this Request for Extension of Time is courteously solicited.

05/05/2003 HGBREH1 00000094 09899784

02 FC:1251

110.00 OP

Respectfully submitted,

[Signature]  
Steve Cha  
Attorney for Applicant(s)  
Registration No. 44,069

CHA & REITER  
411 Hackensack Ave, 9th floor  
Hackensack, NJ 07601  
(201) 518-5518

Date: April 28, 2003

RECEIVED  
MAY - 6 2003  
TC 2800 MAIL ROOM